## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICANT:	GEUN-YOUNG YEOM.	) )Group Art No.: 1765
SERIAL NO.:	10/010,548	) (Examiner: B. X. Tran
FILING DATE:	November 08, 2001	) )
FOR:	METHOD OF ETCHING SEMI- CONDUCTOR DEVICE USING NEUTRAL BEAM AND APPARATUS FOR ETCHING THE SAME	) ) )

## RESPONSE TO RESTRICTION REQUIREMENT WITH AMENDMENT, PURSUANT TO 37 C.F.R. §1.111

The Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450 #6B 8/8/03 mw

Dear Sir or Madam:

In response to a Restriction Requirement of June 27, 2003, please enter and consider the following:

Amendment to the Claims, beginning on page 2 of this paper; and Remarks, beginning on page 3 of this paper.